

501.41175X00/340101349US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant: Hiroyuki NAKANO et al.

APR 18 2005

Serial No.: 10/075,244

Filed: 15 February 2002

For: METHOD AND APPARATUS FOR PLASMA PROCESSING

Group: 1762

Examiner: M. Padgett

Conf. No.: 7857

PETITION FOR EXTENSION OF TIME**Mail Stop AF****EXPEDITED PROCESSING REQUESTED UNDER 37 CFR §1.116**

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

18 April 2005

Sir:

Applicant respectfully petitions for an extension of the shortened statutory period for response to the final Office Action mailed 18 November 2004 in connection with the above-identified application. A Form PTO-2038 authorizing payment of all fees required for entry of this paper is being filed concurrently herewith. Please charge any actual fee deficiency to ATS&K Deposit Account No. 01-2135 (as Case No. 501.41175X00).

Respectfully submitted,

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